## PROCEEDINGS OF SPIE

# 9th International Symposium on Advanced Optical Manufacturing and Testing Technologies

## Meta-Surface-Wave and Planar Optics

Mingbo Pu Xiaoliang Ma Xiong Li Minghui Hong Changtao Wang Xiangang Luo Editors

26–29 June 2018 Chengdu, China

Organized by Institute of Optics and Electronics, Chinese Academy of Sciences (China)

Sponsored by
COS—The Chinese Optical Society (China)
IOE—Institute of Optics and Electronics, Chinese Academy of Sciences (China)

Published by SPIE

Volume 10841

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Please use the following format to cite material from these proceedings:

Author(s), "Title of Paper," in 9th International Symposium on Advanced Optical Manufacturing and Testing Technologies: Meta-Surface-Wave and Planar Optics, edited by Mingbo Pu, Xiaoliang Ma, Xiong Li, Minghui Hong, Changtao Wang, Xiangang Luo, Proceedings of SPIE Vol. 10841 (SPIE, Bellingham, WA, 2019) Seven-digit Article CID Number.

ISSN: 0277-786X

ISSN: 1996-756X (electronic)

ISBN: 9781510623248

ISBN: 9781510623255 (electronic)

Published by

SPIE

P.O. Box 10, Bellingham, Washington 98227-0010 USA Telephone +1 360 676 3290 (Pacific Time) · Fax +1 360 647 1445

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